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Bib Data Sheet

CONFIRMATION NO. 1294

SERIAL NUMBER 09/945,247	FILING DATE 08/31/2001 RULE	CLASS 257	GROUP ART UNIT 2811	ATTORNEY DOCKET NO. 9319T-000281
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APPLICANTS
Seiichiro Higashi, Chino-city, JAPAN;
Daisuke Abe, Suwa-city, JAPAN;

**** CONTINUING DATA ******* *None ins*

**** FOREIGN APPLICATIONS *******
JAPAN 2000-267286 09/04/2000
JAPAN 2001-263559 08/31/2001 *Yes ins*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
**** 10/04/2001**

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 7	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance				
Verified and Acknowledged <i>[Signature]</i> Examiner's Signature	Initials			

ADDRESS
27572

TITLE
Method for fabrication of field-effect transistor *to Reduce Defects At MOS Interfaces Formed*

**FILING FEE
RECEIVED
954**

FEES: Authority has been given in Paper
No. _____ to charge/credit DEPOSIT ACCOUNT
No. _____ for following:

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees (Filing)
<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
<input type="checkbox"/> 1.18 Fees (Issue)
<input type="checkbox"/> Other _____
<input type="checkbox"/> Credit